



Attorney's Docket No.: 4711 USA/P01/W-C/W-C/JB1

Patent

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of: )  
 )  
Steven Verhaverbeke et al. )  
 )  
U.S. Serial No: 09/891,849 )  
 )  
Filed: June 25, 2001 )  
 )  
For: METHOD AND APPARATUS FOR )  
 WAFER CLEANING )  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Examiner: Markoff, Alexander  
Art Unit: 1746

**AMENDMENT AND RESPONSE**

Dear Sir:

This is in response to the Final Office Action mailed March 23, 2005 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicant respectfully requests the Examiner to enter this Preliminary Amendment and consider the following remarks.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP RCE

COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450

U.S. Patent and Trademark Office, Washington, D.C. 20231 on December 22, 2005  
Date of Deposit

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Signature

December 22, 2005

Date